



Cornell University  
Laboratory for Elementary-Particle Physics



# *Detailed Characterization of Vacuum Chamber Surface Properties Using Measurements of the Time Dependence of Electron Cloud Development*

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*Cornell Laboratory for Accelerator-Based Sciences and Education*

*CESRTA Advisory Committee*

*29 August 2012*





# EC Buildup

PEP-II EC Hardware:  
Chicane, SEY station  
Four time-resolved RFA's  
Drift and quadrupole diagnostic  
chambers

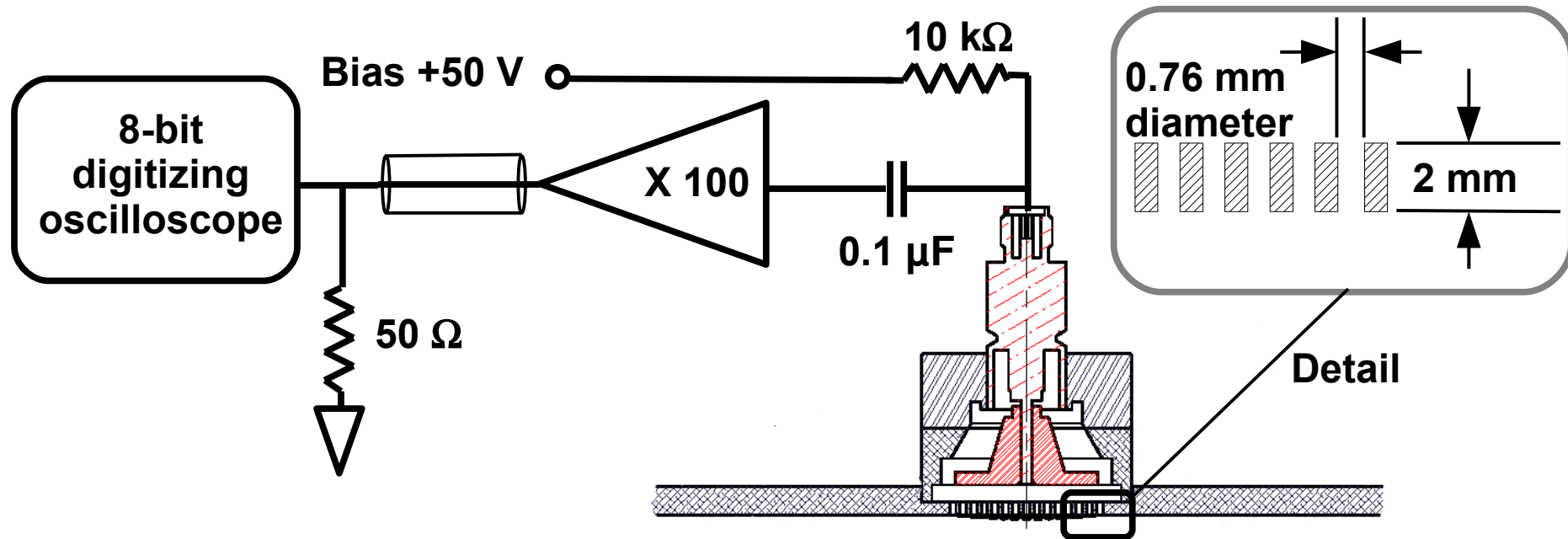


## Locations for collaborator experimental vacuum chambers



**Uncoated aluminum, and TiN, amorphous carbon, diamond-like carbon coatings**

## 30 RFA's in drift regions, dipoles, quadrupoles, and wigglers

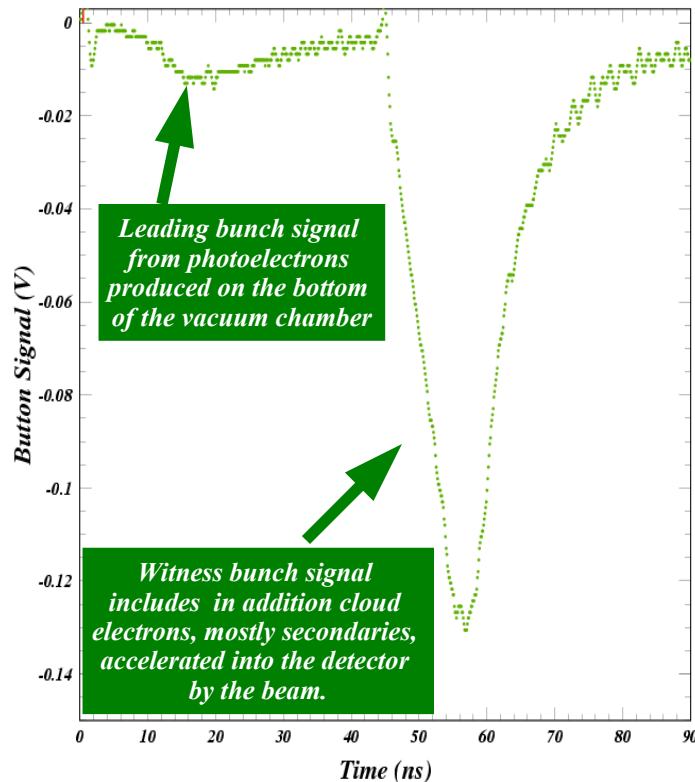


*The pickup electrodes are shielded by the vacuum chamber hole pattern against the beam-induced signal.*

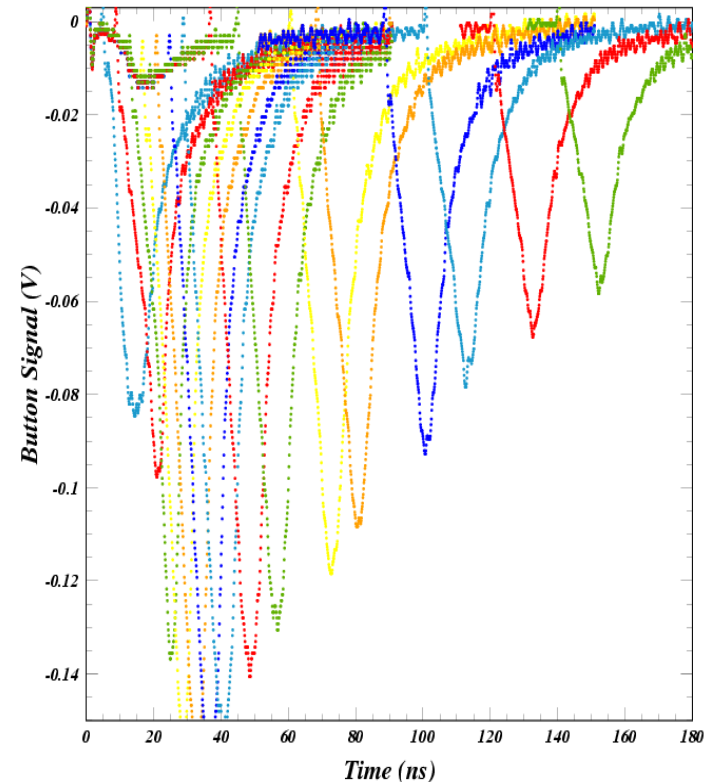
*The positive bias ensures that secondaries produced on the electrode do not escape.*



*Shielded pickup scope trace  
for two bunches 44 ns apart*



*Superposition of 15 such traces  
illustrating the sensitivity to cloud lifetime*



*The single bunch signal arises from photoelectrons produced on the bottom of the vacuum chamber. Its shape is closely related to the photoelectron kinetic energy distribution and the beam kick. The witness bunch signal includes the single-bunch signal as well as the that produced by cloud particles accelerated into the shielded pickup by the kick from the witness bunch. The witness signal is therefore sensitive to SEY.*





# Electron cloud buildup modeling code *ECLOUD*

- \* Originated at CERN in the late 1990's
- \* Widespread application for PS, SPS, LHC, KEK, RHIC, ILC ...
  - \* Under active development at Cornell since 2008
- \* Successful modeling of CESRTA tune shift measurements
  - \* Interactive shielded pickup model implemented in 2010
  - \* Full POSINST SEY functions added as option 2010-2012
  - \* Flexible photoelectron energy distributions added 2011
  - \* Synrad3D photon absorption distribution added 2011

## I. Generation of photoelectrons

- A) Production energy, angle
- B) Azimuthal distribution (v.c. reflectivity)

## II. Time-sliced cloud dynamics

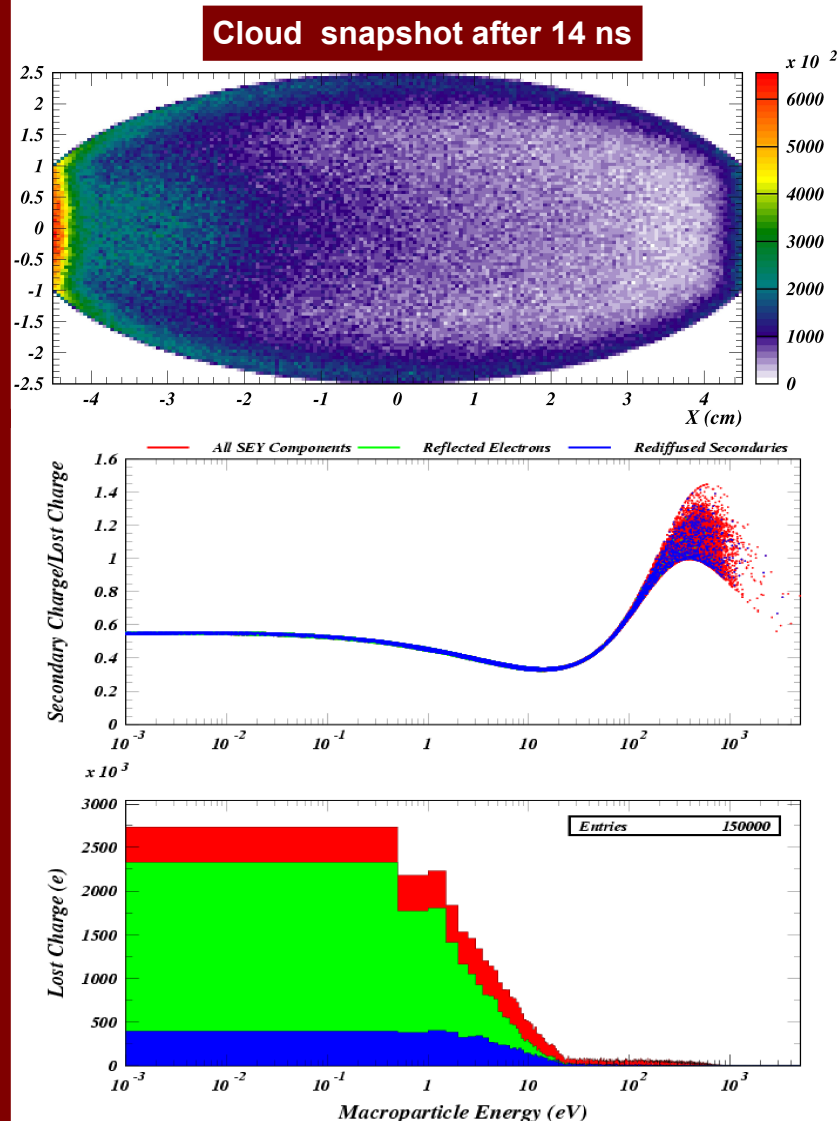
- A) Cloud space charge force
- B) Beam kick
- C) Magnetic fields

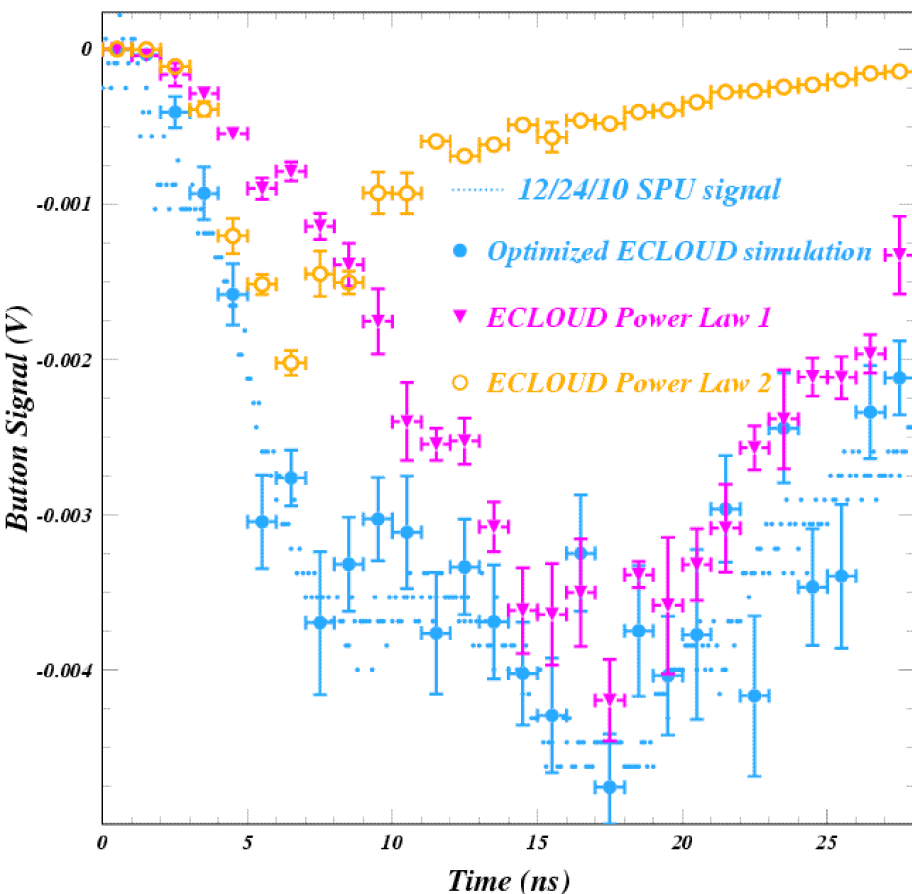
## III. Secondary yield model

- A) True secondaries (yields > 1!)
- B) Rediffused secondaries (high energy)
- C) Elastic reflection (dominates at low energy)

## IV. Shielded pickup model

- A) Acceptance vs incident angle, energy
- B) Signal charge removed from cloud
- C) Non-signal charge creates secondaries





## Two Power-Law Contributions

$$F(E) = E^{P_1} / (1 + E/E_0)^{P_2}$$

$$E_0 = E_{peak} (P_2 - P_1) / P_1$$

This level of modeling accuracy was achieved with the photoelectron energy distribution shown below, using a sum of two power law distributions.

$$E_{peak} = 80 \text{ eV} \quad P_1 = 4 \quad P_2 = 8.4$$

The high-energy component (22%) has a peak energy of 80 eV and an asymptotic power of 4.4. Its contribution to the signal is shown as yellow circles in the lower left plot.

$$E_{peak} = 4 \text{ eV} \quad P_1 = 4 \quad P_2 = 6$$

The low-energy component (78%) has a peak energy of 4 eV and an asymptotic power of 2. Its contribution to the signal is shown as pink triangles.

Electron Cloud Buildup Models and Plans at CESRTA  
JAC et al, LCWS11

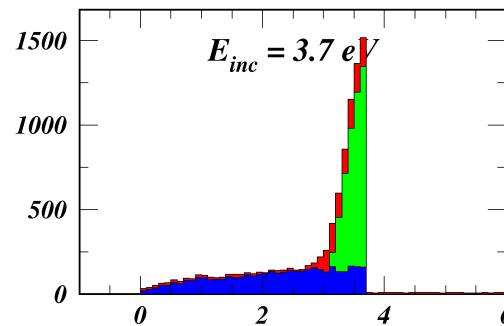
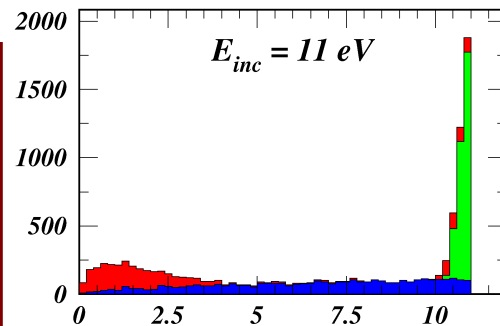
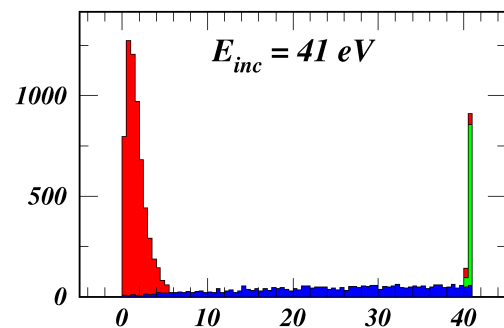
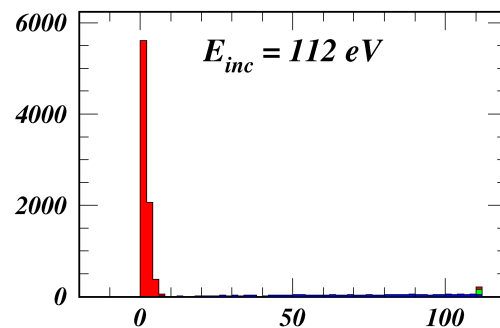
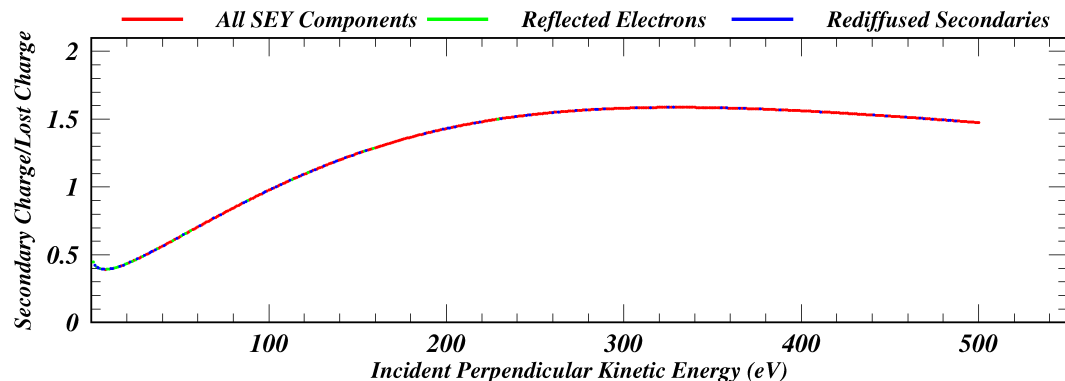
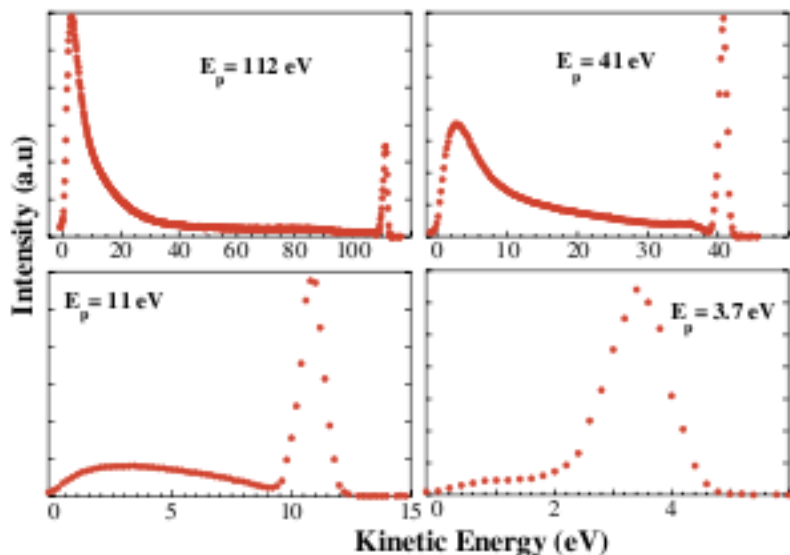
Recent Developments in Modeling Time-resolved Shielded-pickup Measurements  
of Electron Cloud Buildup at CESRTA  
JAC et al, IPAC11



# Modeled secondary electron kinetic energy distributions

Probabilistic Model for the Simulation of Secondary Electron Emission  
M.A.Furman and M.F.F.Pivi, Phys. Rev. ST-AB 5, 124404 (2002)

Can Low-Energy electrons Affect High-Energy Particle Accelerators?  
R.Cimino, et al, Physical Review Letters, Vol. 93, Nr. 1, 014801 (2004)



Secondary Kinetic Energy Distribution (eV)

*The time development of the cloud is directly dependent on secondary kinetic energies and therefore on the relative probabilities of the three secondary production processes.*

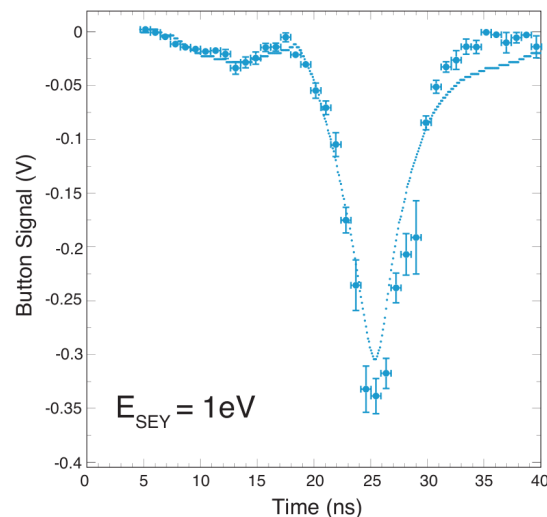
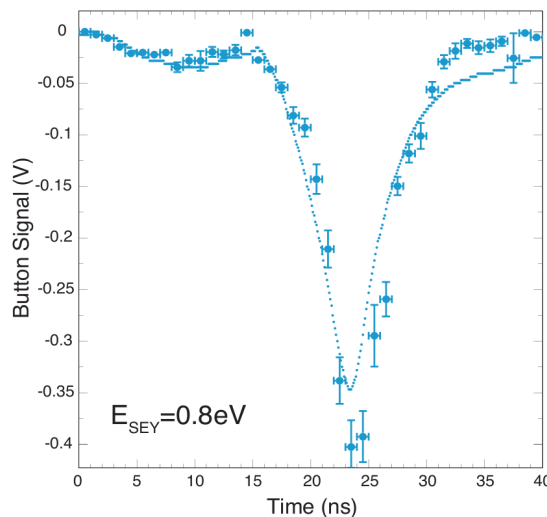
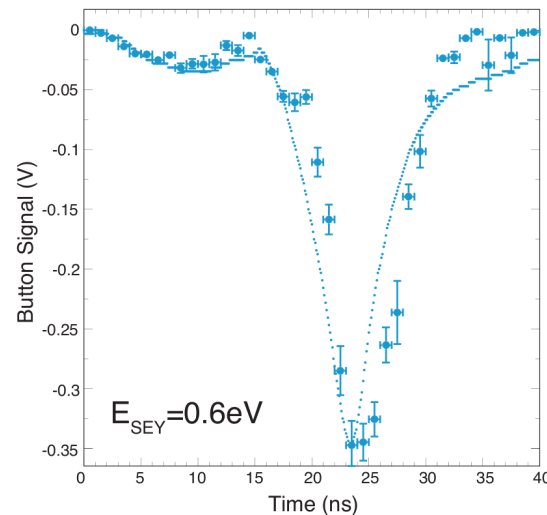
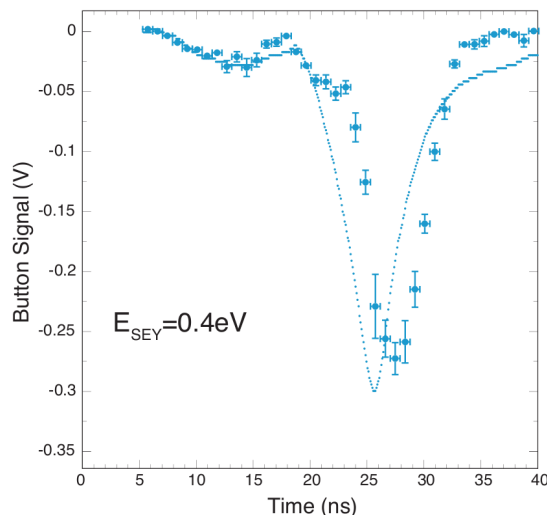


$$f(E_{sec}) \sim E_{sec} \exp(-E_{sec}/E_{SEY})$$

Recent Developments in  
Modeling Time-resolved  
Shielded-pickup  
Measurements  
of Electron Cloud Buildup at  
CESRTA  
JAC et al, IPAC11

Electron Cloud Buildup  
Models and Plans at  
CESRTA  
JAC et al, LCWS11

The CESRTA Test  
Accelerator Electron Cloud  
Research Program Phase 1  
Report  
M.A.Palmer et al, August,  
2012

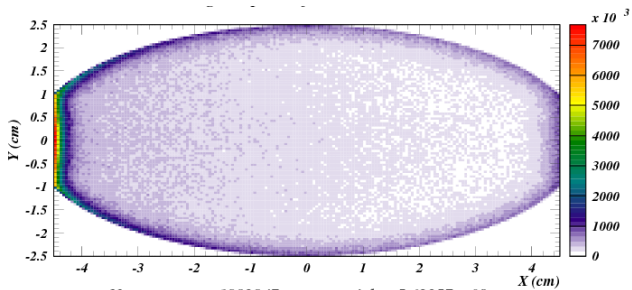


*The pulse shape for the 14-ns witness bunch signal sets a lower bound on the model parameter  $E_{SEY}$ .*

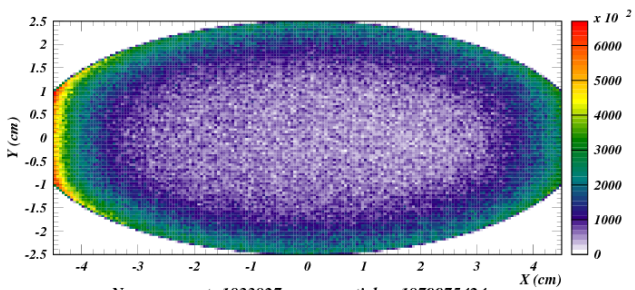




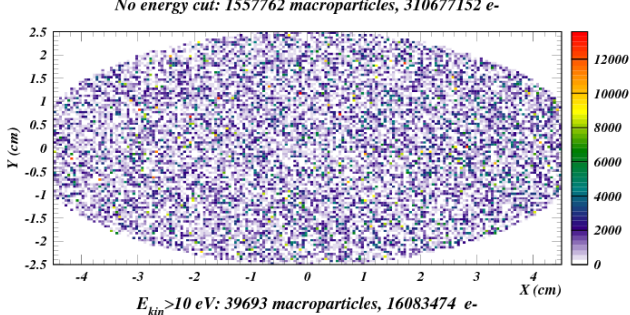
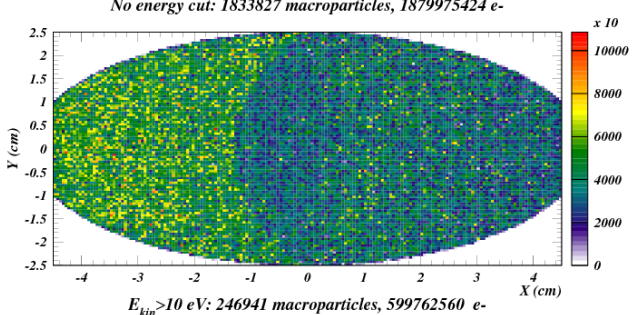
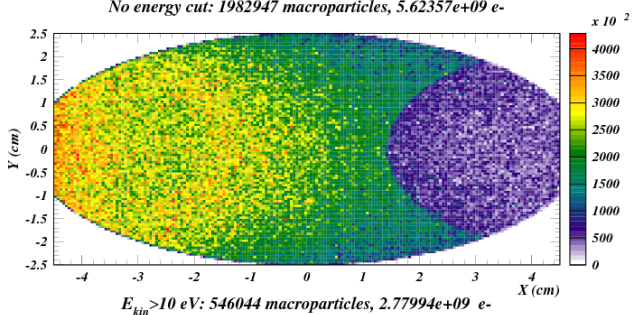
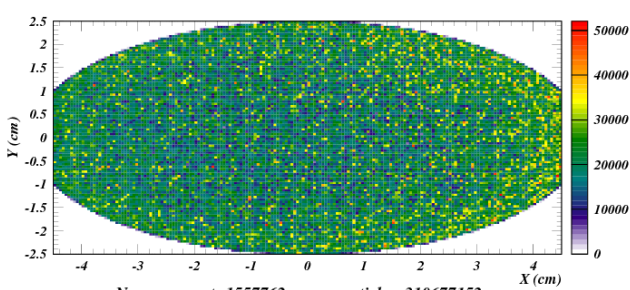
*Prior to 14-ns bunch*



*Prior to 28-ns bunch*



*Prior to 84-ns bunch*

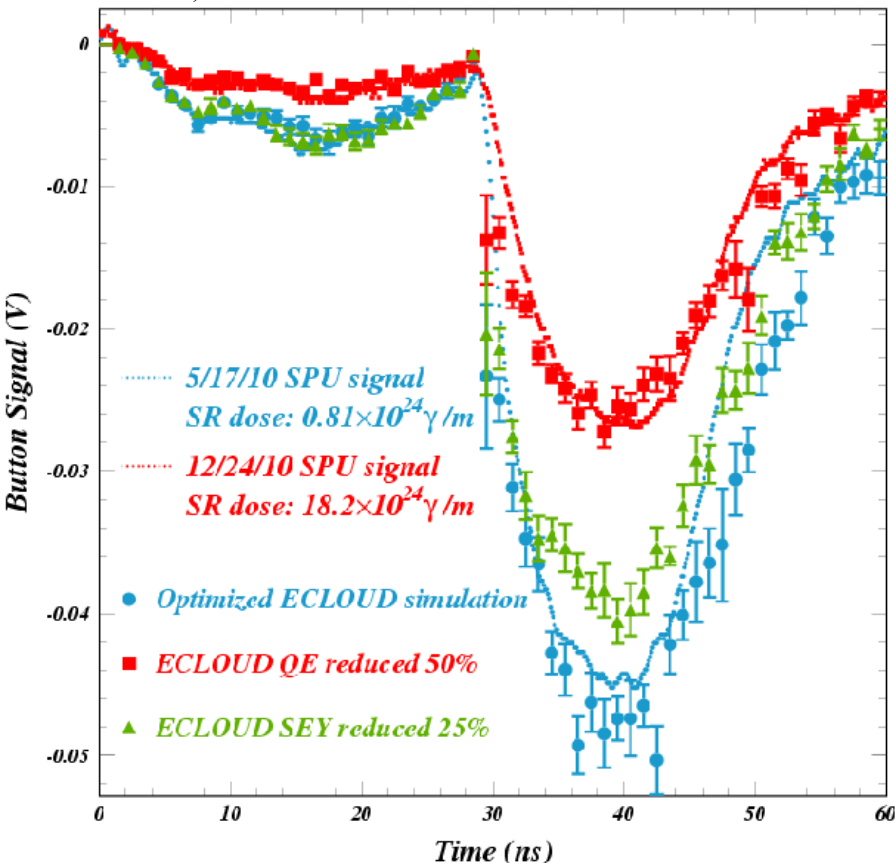


Determines the shielded-pickup signal shape and size.

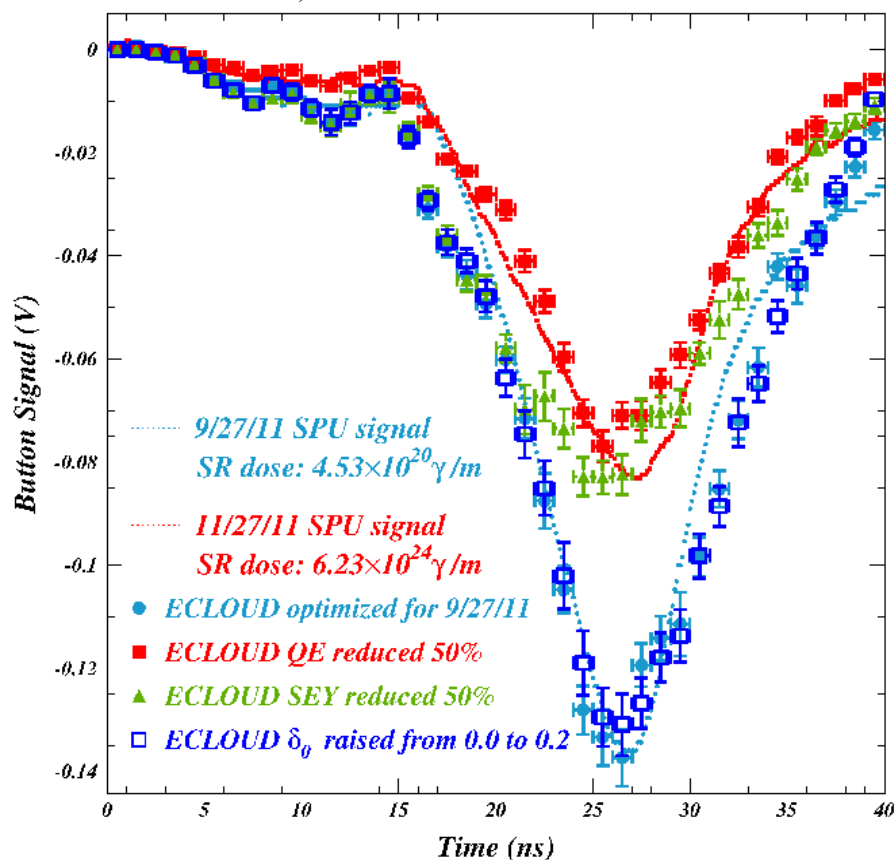


# Beam conditioning effects on an amorphous carbon coating

Recent Developments in Modeling Time-resolved Shielded-pickup Measurements of Electron Cloud Buildup at CESRTA  
JAC et al, IPAC11

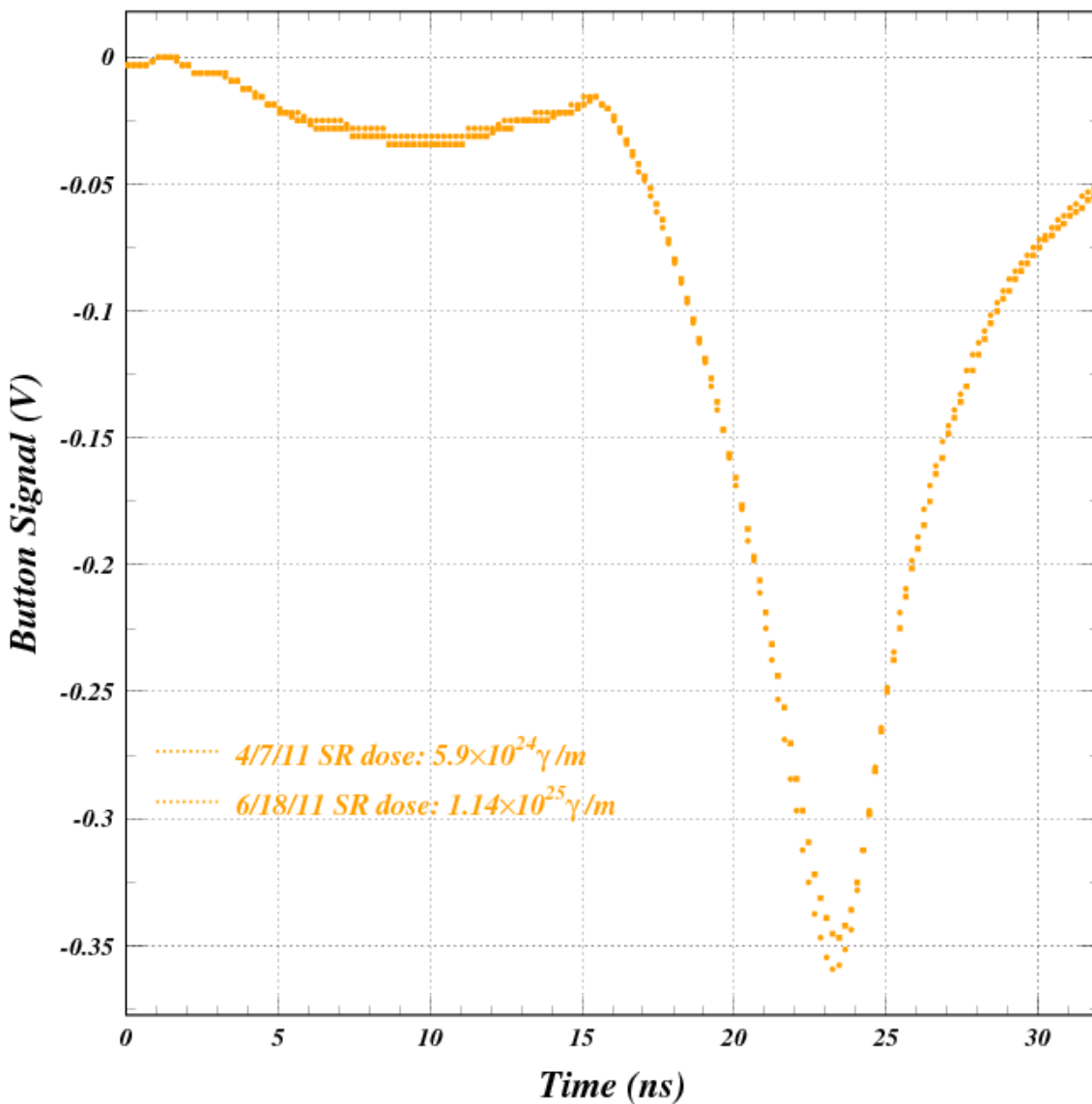


Time-resolved Shielded-pickup Measurements and Modeling of Beam Conditioning Effects on Electron Cloud Buildup at CESRTA  
JAC et al, IPAC12



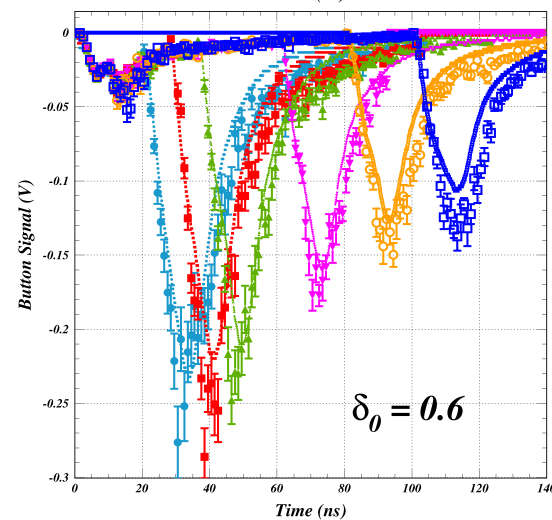
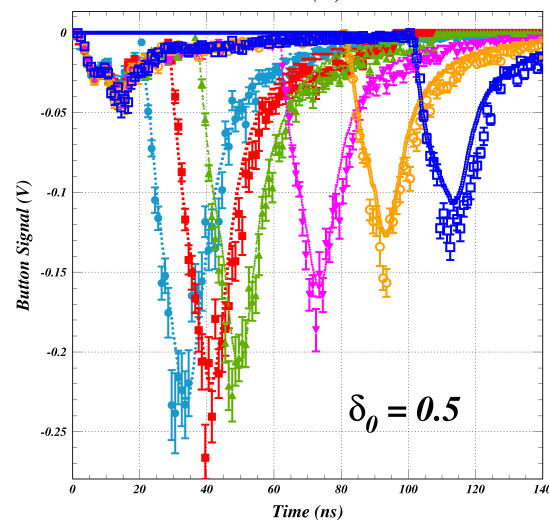
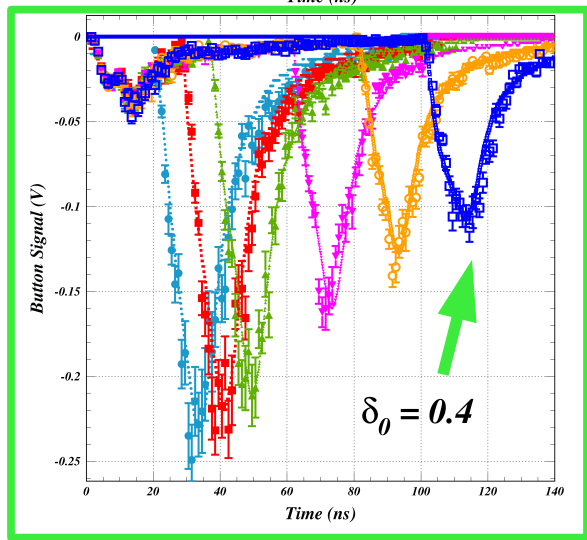
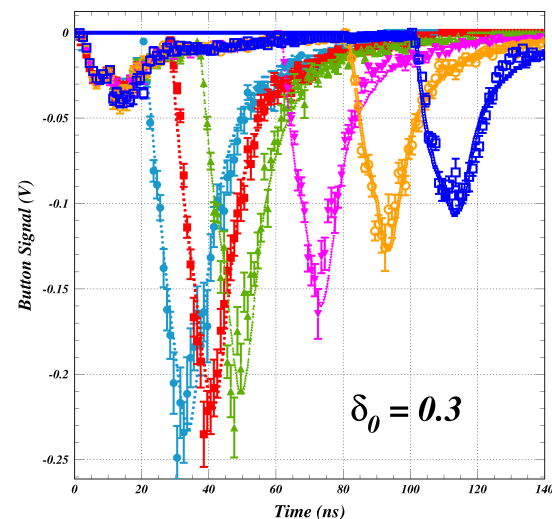
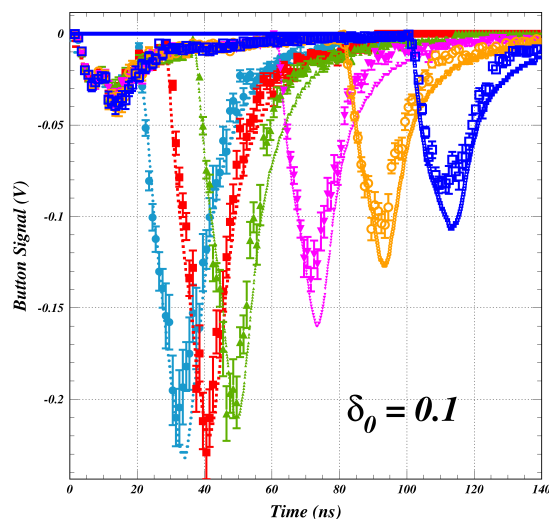
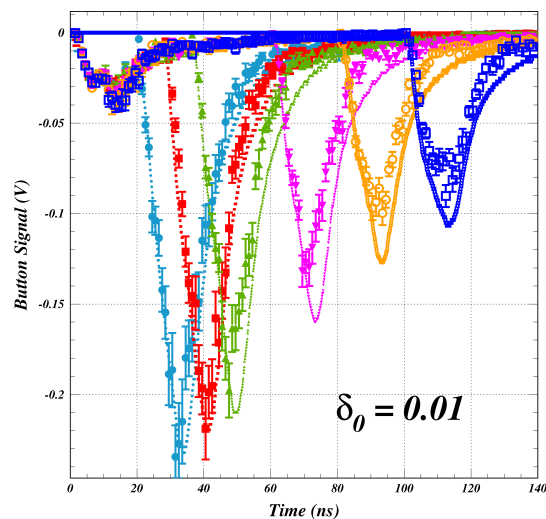
*The beam conditioning effect for an amorphous carbon coating is primarily in quantum efficiency in both the early and late conditioning process.*





*Both the quantum efficiency and secondary yield for the TiN coating is remarkably stable over this range of beam conditioning.*

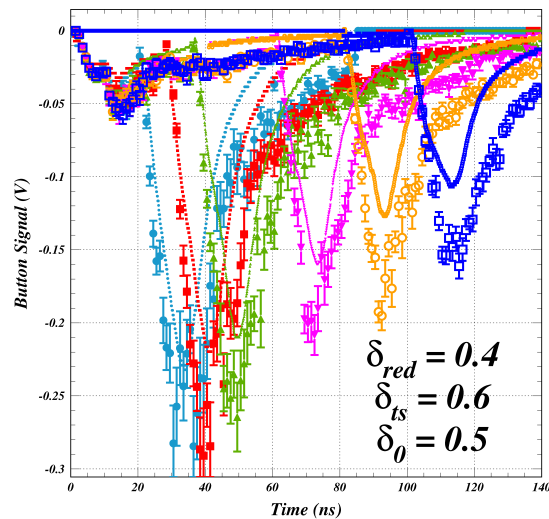
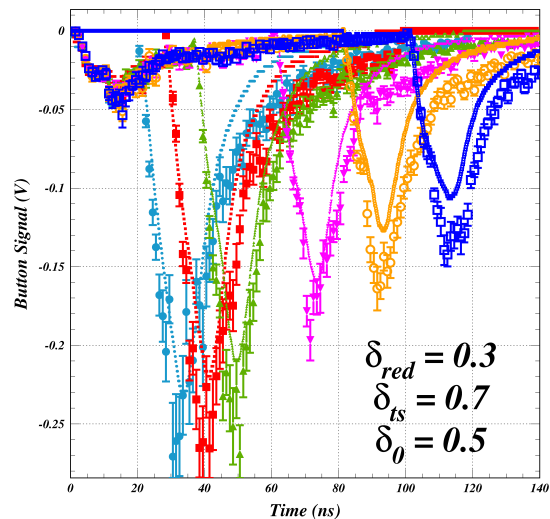
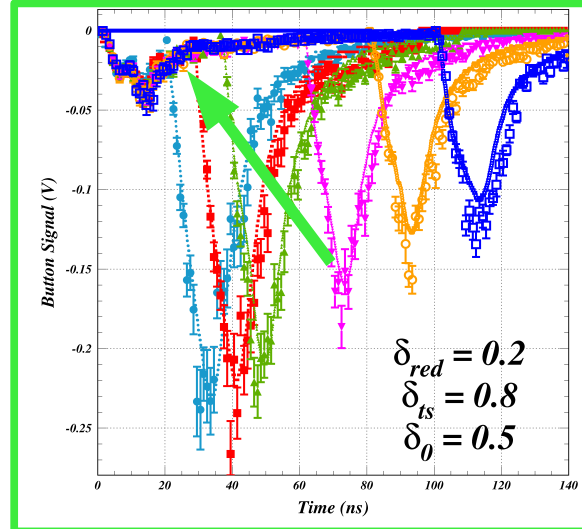
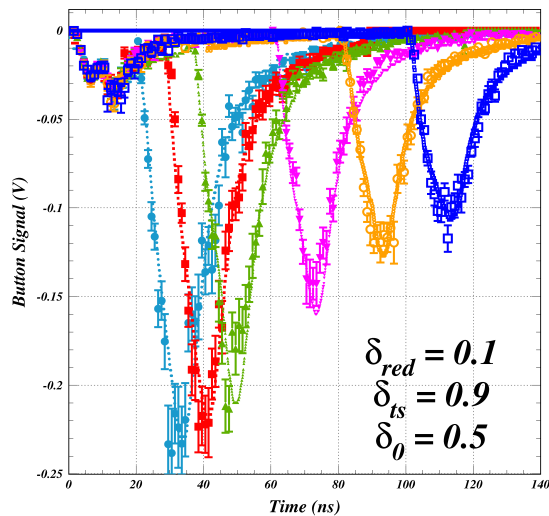
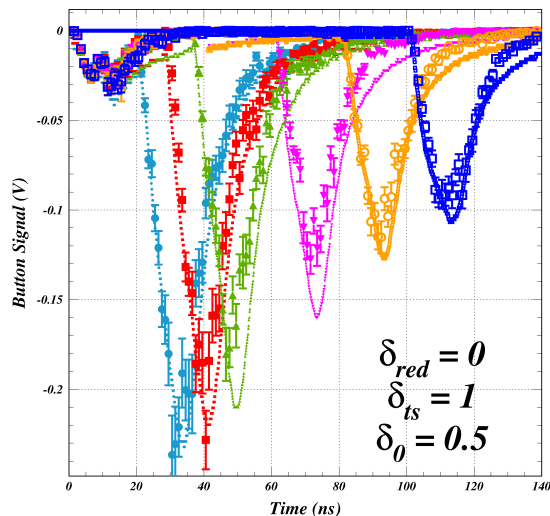
*The reproducibility of the measurement is at the level of a few percent after two months.*



*Sensitivity to value for elastic yield.*



# Discriminating between the true and rediffused secondary yield processes



*The rediffused secondary yield process determines the trailing edge of the signal from a single bunch.*

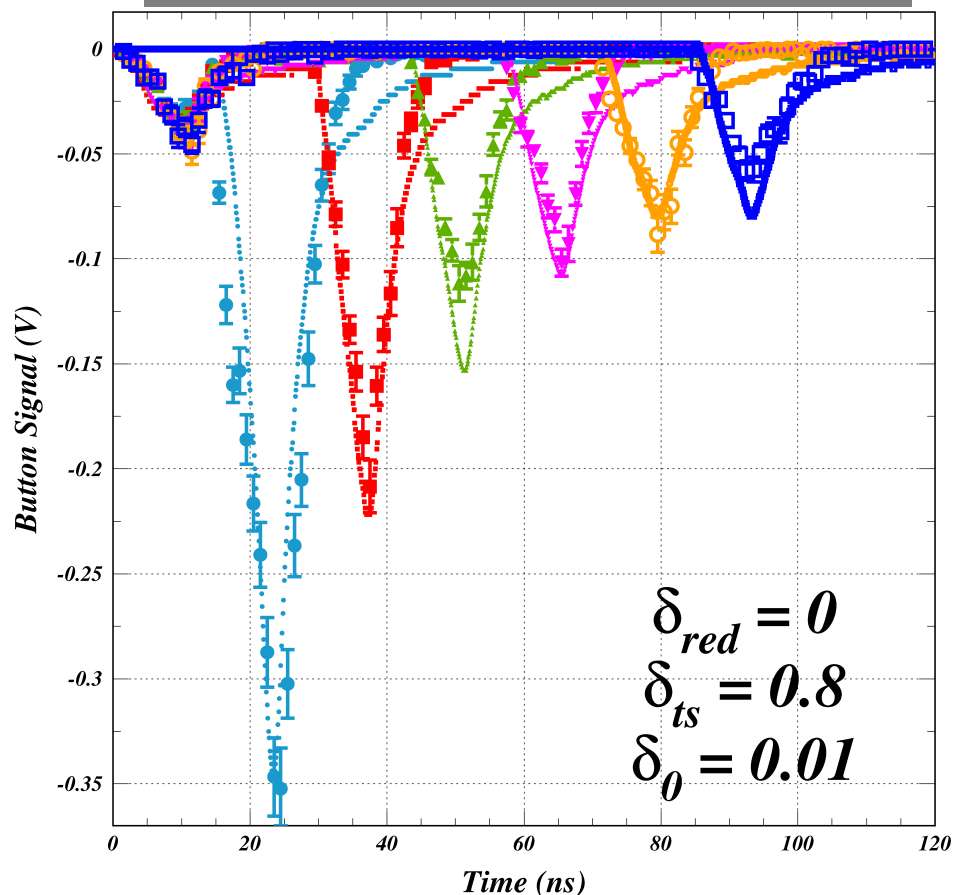
*This trailing edge is insensitive to  $\delta_0$ .*

*The late witness bunch signal used to determine  $\delta_0$  is also sensitive to the rediffused yield process.*

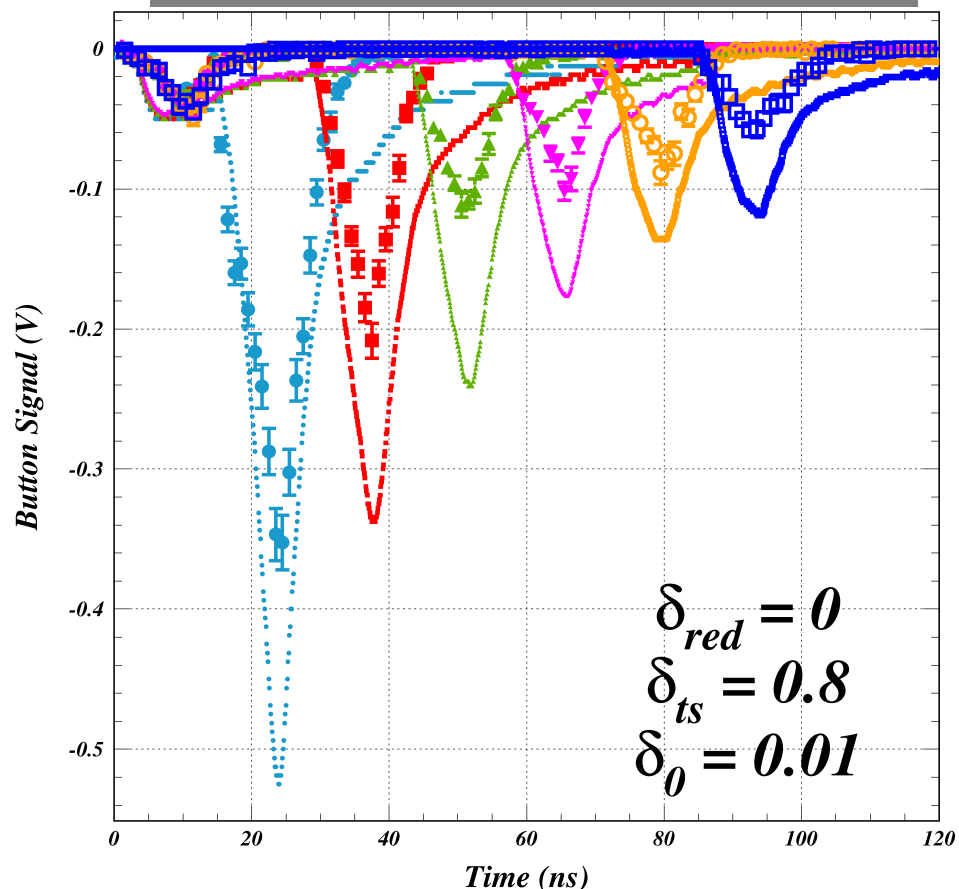
*The witness bunch method provides discriminating power between the true and rediffused processes.*



*Present best model for 6/18/11*



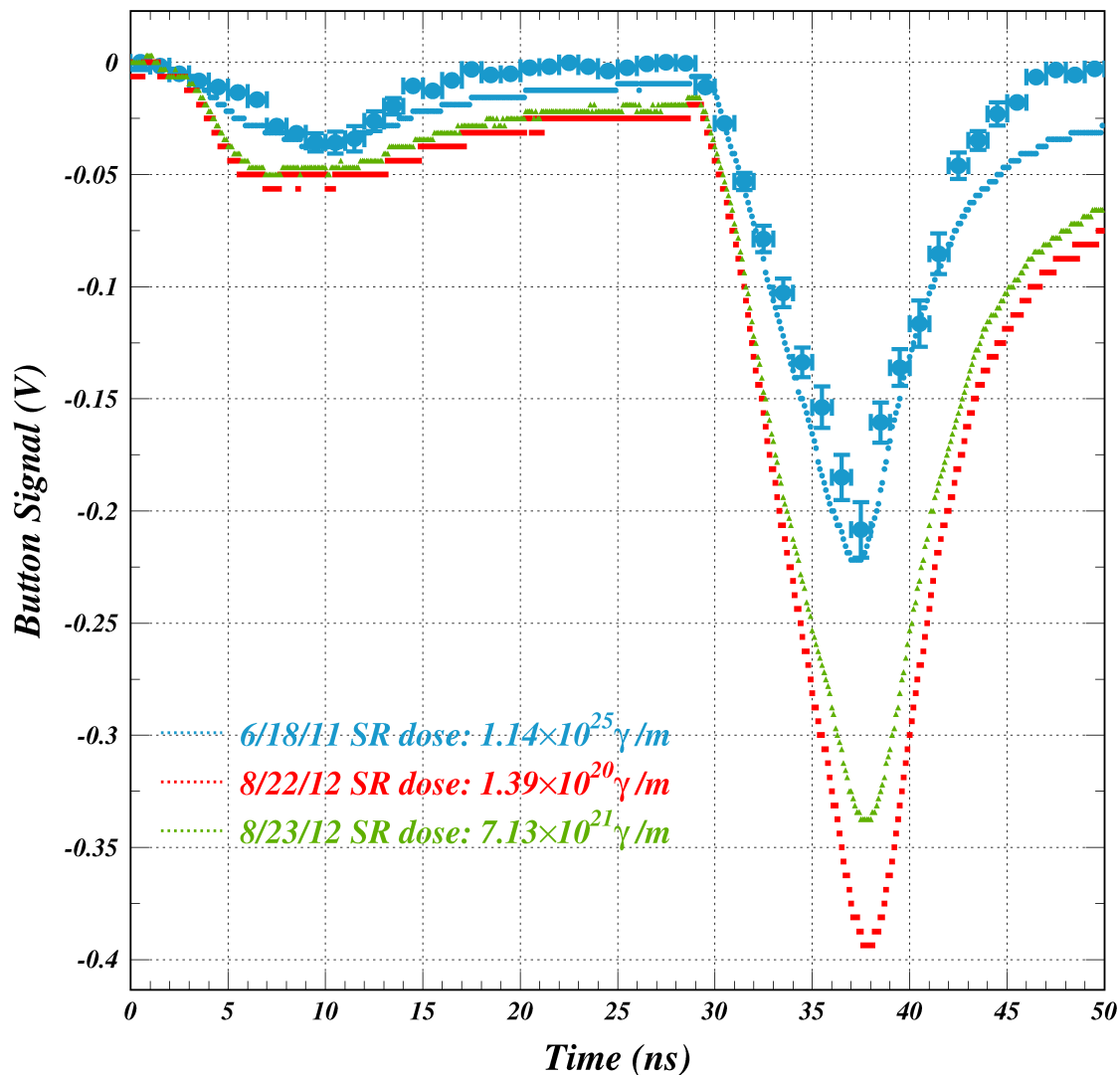
*Same model with 8/22/12 measurements on unconditioned TiN*



*Initial indication is the the quantum efficiency is similar, but there is much more cloud due to SEY.*



*Conditioning comparison: 5.3 GeV e<sup>+</sup> 15W TiN*







Date	Species	Beam Energy (GeV)	Bunch Current (mA)	15E/W	Mitigation Technique	Bunch Spacing (ns)
03/27/2010	Positrons	5.3	5	W E	a-carbon (1) TiN	14-84
	Electrons		5	W E	a-carbon (1) TiN	14-70
05/09/2010	Positrons	2.1	3	W E	Al a-carbon (2)	4-140
	Electrons		3	W E	Al a-carbon (2)	4-20
05/17/2010	Positrons	5.3	3	W E	Al a-carbon (2)	4-100
	Electrons		3	W E	Al a-carbon (2)	4-100
05/19/2010	Electrons	2.1	1	W E	Al a-carbon (2)	4-120
09/21/2010	Positrons	5.3	1,2,4,6,8,10	W E	TiN a-carbon (2)	14
09/24/2010	Positrons	2.1	2,4,6	W E	TiN a-carbon (2)	14
	Electrons			W E	TiN a-carbon (2)	
12/10/2010	Electrons	2.1	1,2,3,4,5,6,8,10	W E	TiN a-carbon (2)	14-84
12/20/2010	Positrons	2.1	1,2,3,4,5,6,8,10	W E	TiN a-carbon (2)	56,84
12/24/2010	Positrons	5.3	3,5	W E	TiN a-carbon (2)	14-84
	Electrons		3,5	W E	TiN a-carbon (2)	14-84
04/07/2011	Positrons	5.3	1,2,3,4,5,6,8,10	W E	TiN DL carbon	14-84
	Electrons			W E	TiN DL carbon	
04/16/2011	Positrons	2.1	1,2,3,4,5,6,8,10	W E	TiN DL carbon	14-84
04/17/2011	Electrons		1,2,3,4,5,6,8,10	W E	TiN DL carbon	14-84
06/11/2011	Positrons	2.1	1,2,3,4,5,6,8,10	W E	TiN DL carbon	14-84
06/12/2011	Electrons		1,2,3,4,5,6,8,10	W E	TiN DL carbon	14-84
	Positrons	5.3		W E	TiN DL carbon	
06/18/2011	Positrons	4.0	1,2,3,4,5,6,8,10	W E	TiN DL carbon	14-98
	Electrons			W E	TiN DL carbon	
06/27/2011	Positrons	2.1	1,2,3,4,5,6	W E	TiN DL carbon	84
	Electrons			W E	TiN DL carbon	
09/27/2011	Positrons	5.3	1,2,3,4,5,6,8	W E	a-carbon (2) DL carbon	14-84
09/30/2011	Positrons	5.3	1,2,3,4,5,6,8	W E	a-carbon (2) DL carbon	14-84
10/04/2011	Positrons	5.3	1,2,3,4,5,6,8	W E	a-carbon (2) DL carbon	14-84
10/11/2011	Positrons	5.3	1,2,3,4,5,6,8	W E	a-carbon (2) DL carbon	14-84
10/25/2011	Positrons	5.3	1,2,3,4,5,6,8	W E	a-carbon (2) DL carbon	14-84
11/27/2011	Positrons	5.3	1,2,3,4,5,6,8,10	W E	a-carbon (2) DL carbon	14-98
	Electrons			W E	a-carbon (2) DL carbon	

*2.1, 4.0, and 5.3 GeV*

*Electron and positron beams*

*1-10 mA/bunch*

*Uncoated aluminum*

*TiN-coated aluminum*

*Two amorphous-carbon coatings*

*Diamond-like carbon coating*

*Unconditioned uncoated aluminum*

*Unconditioned TiN coating*

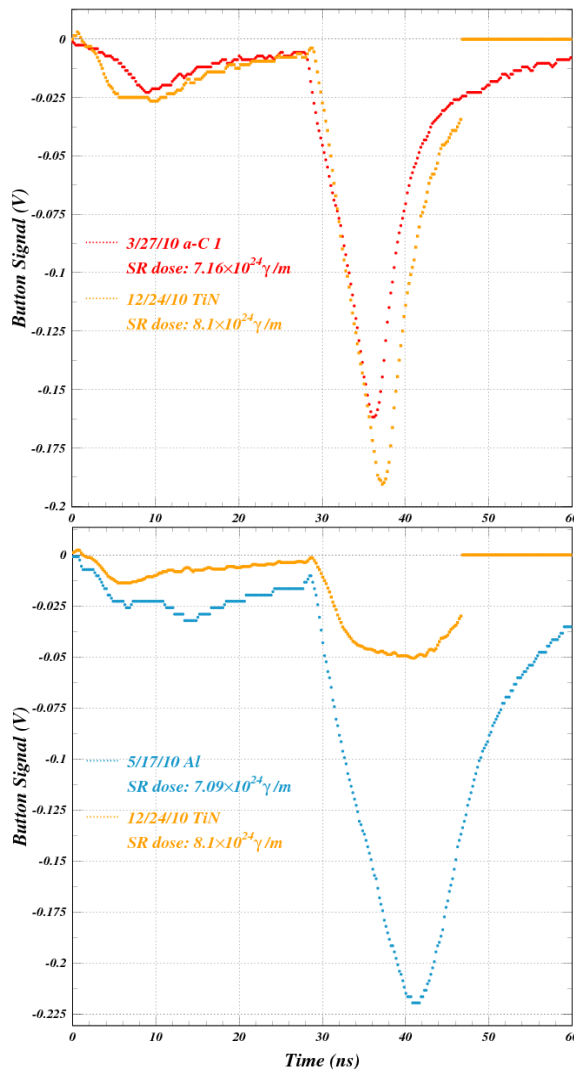
*Unconditioned a-carbon coating*

*4-ns, 14-ns bunch spacings up to 140 ns*





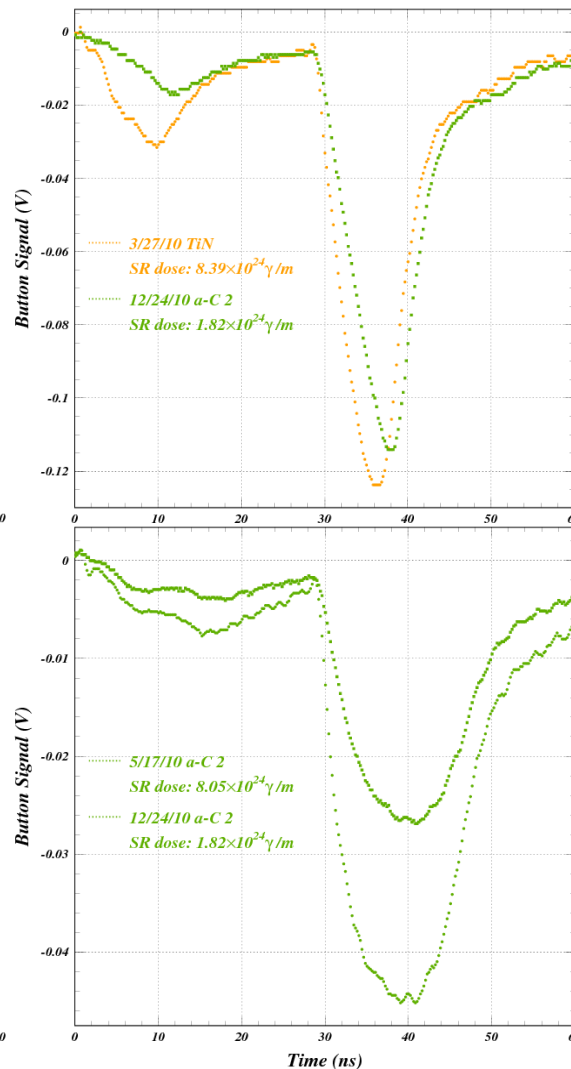
**15W**



*The a-carbon coating suppresses high-energy photoelectrons compared to the TiN coating.*

*The quantum efficiency for reflected photons and the SEY are both much smaller for the TiN coating compared to uncoated aluminum.*

**15E**



**5 mA/bunch**

*The results for the second a-carbon-coated chamber corroborate the high-energy photoelectron suppression relative to TiN observed with the first a-carbon-coated chamber.*

**3 mA/bunch**

*The second carbon-coated chamber shows conditioning effects between 5/17/10 and 12/24/10, primarily for the quantum efficiency.*

